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	Application No.	Applicant(s)	
	10/618,068	NAKAMURA ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Ling-Siu Choi	1713	
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apply or other appropriate communication IGHTS. This application is subject to	plication. If not include will be mailed in due	ed course. THIS
1. X This communication is responsive to the Amendment filed	<u>12/05/2006</u> .		
2. X The allowed claim(s) is/are <u>1-21</u> .			
 Acknowledgment is made of a claim for foreign priority ur a)	e been received.		
Certified copies of the priority documents have			
3. Copies of the certified copies of the priority do	cuments have been received in this	national stage applicat	tion from the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the rec	quirements
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF
5. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) including changes required by the Notice of Draftspers	son's Patent Drawing Review (PTO-	948) attached	
1) hereto or 2) to Paper No./Mail Date			
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C	office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on the drawin he header according to 37 CFR 1.121(c	ngs in the front (not the d).	back) of
 DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT 	SIT OF BIOLOGICAL MATERIAL IN FOR THE DEPOSIT OF BIOLOGICA	nust be submitted. N AL MATERIAL.	lote the
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Attachment(s)			
1. Notice of References Cited (PTO-892)	5. Notice of Informal P	, ,	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	 Interview Summary Paper No./Mail Dat 		
 Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 	7. Examiner's Amendn	nent/Comment	
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. X Examiner's Stateme	nt of Reasons for Allo	wance
or biological material	9. Other		
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Application/Control Number: 10/618,068

Art Unit: 1713

DETAILED ACTION

This Office Action is in response to the Amendment filed December 5, 2006.
 Claims 1-21 are now pending.

Allowable Subject Matter

- 2. Claims 1-21 are allowed.
- 3. The following is an examiner's statement of reasons for allowance:

The present claims are allowable over the closest references: Kenji et al. (JP 54-092526).

Summary of claim 1:

A re	esin composition comprising
Α	an alkali-soluble resin
В	an infrared absorbing agent having
	a maximum absorption wavelength in the range of 760 nm to 1200 nm and
С	a thiol compound
whe	erein a solubility of the resin composition in an alkaline aqueous solution is
cha	nged by exposure with an infrared laser beam

Kenji et al. disclose a masking material as ink or coating, comprising a SH groupcontaining organic sulfur compound with acid stability and heat resistance, an amine Art Unit: 1713

compound, and phenolic and/or rosin type alkali soluble resin, wherein the -SH group-containing organic sulfur compound is listed in Table 1 (page 142). However, Kenji et al. do not teach a resin composition comprising an alkali-soluble resin; an infrared absorbing agent having a maximum absorption wavelength in the range of 760 nm to 1200 nm; and a thiol compound, wherein a solubility of the resin composition in an alkaline aqueous solution is changed by exposure with an infrared laser beam.

In light of the above discussion, it is evident as to why the present claims are patentable over the prior art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ling-Siu Choi whose telephone number is 571-272-1098.

If attempt to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Wu, can be reach on 571-272-1114.

LING-SUI CHOI CHIMARY EXAMINER

February 1, 2007

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